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| Search Notes  | Application/Control No. 10087699 | Applicant(s)/Patent Under Reexamination CHENG ET AL. |
| | Examiner David M Naff | Art Unit 1657 |

| SEARCHED | | | |
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| Class | Subclass | Date | Examiner |
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| SEARCH NOTES | | |
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| Search Notes | Date | Examiner |
| West-see search history | 5/22/08 | DMN |
| West-see search history | 10/21/08 | DMN |

| INTERFERENCE SEARCH | | | |
|---------------------|----------|------|----------|
| Class | Subclass | Date | Examiner |
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